Intended Use: The instrument is intended to be used in the following experiments:

(1) Using immunocytochemical methods at the ultrastructural level, the normal cellular distribution of known trafficking molecules, and their altered localization in Hermansky-Pudlak Syndrome cell lines will be assessed.

(2) To determine whether transgenic techniques designed to interrupt the cytoskeleton were successful in disrupting the structure of the intermediate filament component of the cytoskeleton.

(3) Circadian transplant studies to confirm that graft efferents actually establish synaptic contacts with host brain regions among animals exhibiting different patterns of behavioral recovery.

(4) Studies on transgenic mouse lines in which the endogenous surfactant protein B (SP–B) gene has been inactivated and replaced with a human transgene encoding a deleted/mutated SP–B proprotein.

Application accepted by Commissioner of Customs: December 28, 2001.

Docket Number: 02–001. Applicant: University of Vermont, Department of Orthopaedics, Burlington, VT 05405. Instrument: Upgrade for X-ray based Motion Analysis System. Manufacturer: RSA BioMedical Innovations AB, Sweden. Intended Use: The instrument is intended to be used to make measurements of the biomechanical behavior of different joints of the body and to study different types of joint trauma, surgical repair, and healing responses. Application accepted by Commissioner of Customs: January 22, 2002.

Docket Number: 02-002. Applicant: Fox Chase Cancer Center, 7701 Burholme Avenue, Philadelphia, PA 19111. Instrument: Electron Microscope, Model Tecnai 12 BioTWIN. Manufacturer: FEI Company, The Netherlands. Intended Use: The instrument is intended to be used to study biological materials including nucleic acids, proteins, organelles, cultured cells, and tissues prepared for electron microscopy. Specifically, studies of ultrastructure and the intracellular localization and trafficking of biologically important molecules including chromatin, structures critical to the regulation of DNA replication, cytokinesis, and meiosis, products of oncogene and tumor suppressor genes, and viral components. Application accepted by Commissioner of Customs: January 22, 2002.

Docket Number: 02–003. Applicant: Albert Einstein College of Medicine of Yeshiva University, 1300 Morris Park Avenue, Bronx, NY 10461. Instrument: Electron Microscope, Model Tecnai 20. Manufacturer: FEI Company, The Netherlands. Intended Use: The instrument is intended to be used to study the structure of biological macromolecular complexes and to determine the 3-dimensional structure of the cytoskeleton of normal metastatic mammalian cells and the mechanism of intracellular transport and cell movement. Application accepted by Commissioner of Customs: January 22, 2002.

Gerald A. Zerdy,

Program Manager, Statutory Import Programs Staff.

[FR Doc. 02–4669 Filed 2–26–02; 8:45 am]
BILLING CODE 3510–DS–P

DEPARTMENT OF COMMERCE

International Trade Administration

The Scripps Research Institute; Notice of Decision on Application for Duty-Free Entry of Electron Microscope

This is a decision pursuant to section 6(c) of the Educational, Scientific, and Cultural Materials Importation Act of 1966 (Pub. L. 89–651, 80 Stat. 897; 15 CFR part 301). Related records can be viewed between 8:30 A.M. and 5:00 P.M. in Suite 4100W, U.S. Department of Commerce, Franklin Court Building, 1099 14th Street, NW., Washington, DC.

Docket Number: 01–022. Applicant:
The Scripps Research Institute, La Jolla,
CA 92037. Instrument: Electron
Microscope, Model Tecnai F20T.
Manufacturer: FEI Company, The
Netherlands. Intended Use: See notice at
67 FR 2196, January 16, 2002. Order
Date: March 30, 2001.

Comments: None received. Decision: Approved. No instrument of equivalent scientific value to the foreign instrument, for such purposes as the instrument is intended to be used, was being manufactured in the United States at the time the instrument was ordered. Reasons: The foreign instrument is a conventional transmission electron microscope (CTEM) and is intended for research or scientific educational uses requiring a CTEM. We know of no CTEM, or any other instrument suited to these purposes, which was being manufactured in the United States at the time of order of the instrument.

Gerald A. Zerdy,

Program Manager, Statutory Import Programs Staff.

[FR Doc. 02–4667 Filed 2–26–02; 8:45 am] **BILLING CODE 3510–DS–P**

DEPARTMENT OF COMMERCE

International Trade Administration

University of Georgia, Athens: Notice of Decision on Application for Duty-Free Entry of Electron Microscope

This is a decision pursuant to section 6(c) of the Educational, Scientific, and Cultural Materials Importation Act of 1966 (Pub. L. 89–651, 80 Stat. 897; 15 CFR part 301). Related records can be viewed between 8:30 A.M. and 5 P.M. in Suite 4100W, U.S. Department of Commerce, Franklin Court Building, 1099 14th Street, NW., Washington, DC.

Docket Number: 01–023. Applicant: University of Georgia, Athens, GA 30602–2403. Instrument: Electron Microscope, Model Tecnai 20. Manufacturer: FEI Company, The Netherlands. Intended Use: See notice at 67 FR 4393, January 30, 2002. Order Date: May 11, 2001.

Comments: None received. Decision: Approved. No instrument of equivalent scientific value to the foreign instrument, for such purposes as the instrument is intended to be used, was being manufactured in the United States at the time the instrument was ordered. Reasons: The foreign instrument is a conventional transmission electron microscope (CTEM) and is intended for research or scientific educational uses requiring a CTEM. We know of no CTEM, or any other instrument suited to these purposes, which was being manufactured in the United States at the time of order of the instrument.

Gerald A. Zerdy,

Program Manager, Statutory Import Programs Staff.

[FR Doc. 02–4668 Filed 2–26–02; 8:45 am] BILLING CODE 3510–DS–P

DEPARTMENT OF COMMERCE

International Trade Administration

Secretarial Business Development Mission to China, April 21–25, 2002

AGENCY: International Trade Administration, Department of Commerce.

ACTION: Notice to announce Secretary Evans' business development mission to China during April 21–25, 2002.

SUMMARY: Secretary of Commerce Donald L. Evans will lead a senior-level business development mission to Beijing and Shanghai, China, on April 21–25, 2002, in conjunction with the 14th session of the U.S.-China Joint Commission on Commerce and Trade (JCCT) to be held in Beijing the week of